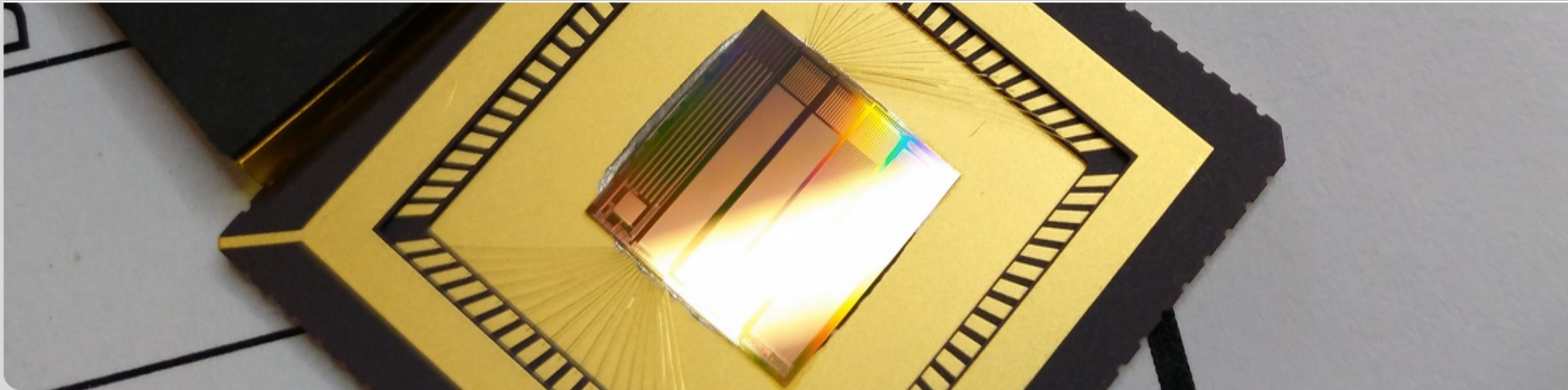


PisaMeeting2018 – Solid State Detectors – Poster Slide

R. Schimassek – Monolithic Sensors in LFoundry Technology: Concepts and Measurements

Institute for Data Processing and Electronics (IPE)



Monolithic Sensors in LFoundry Technology: Concepts and Measurements

R. Schimassek, R. Blanco, R. Casanova Mohr, F. Ehrler, I. Perić,
E. Vilella Figueras, H. Zhang

- Particle Detectors produced in LFoundry LFA150 (150 nm) CMOS process
- Functional tests on a triggered readout scheme for cluster readout (PPTb)
- First Light on the Waveform Sampling Detector

